

INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>(Use several sheets if necessary)</small>			Docket Number (Optional) AKM-00301		Application No. <div style="font-size: 2em; font-family: cursive;">525802</div>	
			Applicant I. Hidaka			
			Filing Date March 15, 2000		Group Art Unit	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
LC	AL 8-274167	10-18-96	Japan	—	—	
	AM					
	AN					
	AO					
	AP					
OTHER DOCUMENTS <small>(Including author, Title, Date, Pertinent Pages)</small>						
LC	AQ	"Glossary of Semiconductor and IC terms" (edited by Takahiko Iida et al., Ohmsha, Ltd., 1980)				
LC	AR	"Comprehensive Glossary of ULSI terms" (issued by Hirotaka Motoyama, Science Forum, Ltd.,				
	AS	1988)				
	AT					
	AU					
	AV					
	AW					
	AX					
	AY					
EXAMINER <div style="font-family: cursive; font-size: 1.5em;">[Signature]</div>				DATE CONSIDERED 6-16-00		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						